



Re application of : Raaijmakers et al.  
 App. No. : 09/764,711  
 Filed : January 18, 2001  
 For : METHOD OF DEPOSITING  
 SILICON WITH HIGH STEP  
 COVERAGE  
 Examiner : A. Roman  
 Art Unit : 2812

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

May 8, 2003

(Date)

*Adeel S. Akhtar*

Adeel S. Akhtar, Reg. No. 41,394

COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated as shown below:

CLAIMS AS FILED					
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
Total Claims	6	20	= 0 ×	\$18	= \$0
Independent Claims	2	3	= 0 ×	\$84	= \$0
If application has been amended to contain multiple dependent claim(s), then add				\$280	= \$0
Time Extension Fee					\$0
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0

- (X) Information Disclosure Statement with Form PTO 1449 and 1 reference
- (X) Return prepaid postcard.
- (X) Please charge any additional fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410.

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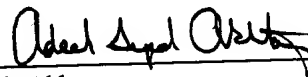
Case Docket No. ASMEX.186DV1

Date: May 8, 2003

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